

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Sun et al.

Examiner: Thanh V. Pham

Serial No.: 10/621,292

Group Art Unit: 2823

Filed: July 17, 2003

For: **METHOD OF FABRICATING SEMICONDUCTOR DEVICE USING A
NICKEL SALICIDE PROCESS**

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT

Sir:

In response to the Final Office Action dated September 13, 2006, please amend the above-referenced patent application as set forth below. Also, accompanying this amendment is a Request for Continued Examination (RCE).
